

<b>IN THE UNITED STATES PATENT AND TRADEMARK OFFICE</b>	Application Number	<b>10/000,009</b>
	Filing Date	<b>December 04, 2001</b>
	First Named Inventor	<b>SAITO</b>
	Group Art Unit	<b>1763</b>
	Examiner Name	<b>Zervigon, Rudy</b>
	Attorney Docket Number	<b>2922-161</b>
Title: <b>LOW PRESSURE CVD APPARATUS AND METHOD OF MANUFACTURING A THIN FILM</b>		

**AMENDMENT AND REQUEST FOR RECONSIDERATION**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

**RECEIVED**  
**DEC 15 2003**  
**TC 1700**

In response to the outstanding Office Action mailed September 10, 2003, please consider the following remarks.

**IN THE CLAIMS:**

Amendments to the Claims are reflected in the listing of claims, which begin on page 2 of this paper.